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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re the Application of

Kazunori SAKURAI et al.

Application No.: 09/843,924

Filed: April 30, 2001

Docket No.: 109182

For: METH

METHOD FOR FORMING PUMP, SEMICONDUCTOR DEVICE AND METHOD FOR MAKING THE SAME, CIRCUIT BOARD, AND SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. English-language Abstracts of the non-English language references 3 and 6 are attached hereto.
- 3. EP 0 766 310 A2 corresponds with JP A 9-97791; and 6,093,964 corresponds with JP 10-50708.

Respectfully submitted,

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JAO:EDM/sdk

Date: July 6, 2001

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